Serial No.

Docket No. 140264

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: XIAOLEI SHI, ET AL	Group Art Unit:						
Serial No.:	Examiner:						
Filed:	•						
For NEAR FIELD OPTICAL STORAGE MASK LAYER, DISK, AND FABRICATION METHOD	· :						
INFORMATION DISCLO	SURE STATEMENT						
✓ 1 Pursuant to 37CFR 1.97(b)							
	[within 3 months of national, non-CPA filling or prior to 1st Office Action] no charge						
	Certification Pursuant to 37 CFR 1.97(c)(1) [before Final Office Action, Allowance, or other action closing prosecution] no charge						
3 Fee Payment Pursuant to 37 CFR 1.9							
[before Final Office Action, Allowance, or other acti	•						
[On or before issue fee payment] \$180.00	4 Certification & Fee Payment Pursuant to 37 CFR 1.97(d) [On or before issue fee payment] \$180.00						
ATTN: MAILSTOP PATENT APPLICATION COMMISSIONER FOR PATENTS ALEXANDRIA, VA 22313-1450							
Sir:							
The following are submitted in the above appli CFR 1.98:	·						
identified document and a transla non-English language document Searching Authority for a patent	1449 or Substitute together with copies of each ation thereof or a concise explanation of each or a Search Report from an Internationa application filed via the Patent Cooperation application or the priority application.						
I hereby certify that this correspondence is bei Service as first class mail in an envelope at Patents, Washington, D.C. 20231, on the date	ddressed to: Assistant Commissioner for !						
Date of Dep							
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Signature	,						

This paper	is súbr	nitted ir	n accordance with:			
	X 6	37 CF Action		s of national, non-CPA filing or prior to 1st Office		
	7		FR 1.97(c): [before Final Of g prosecution, whichever is	fice Action, Allowance, or other action earlier]; and		
		8 🗌	The required Certification r	nade in item 11 below;		
		9		in 37 CFR 1.17(p) for submission of Statement is authorized in item 15 below.		
	□ 10	37 CF	FR 1.97(d): [on or before iss	sue fee payment]; and		
		a)	The required Certification is	stated in item 11 below; and		
		b)		in 37 CFR 1.17(p) for submission of Statement is authorized in item 14 below.		
11 Certification						
		□ 12	any communication from	ontained in this Statement was first cited in a foreign patent office in a counterpart not more than three months prior to the		
		□ 13	from a foreign patent office to the knowledge of the per reasonable inquiry, no Statement was known to	Statement was cited in a communication in a counterpart foreign application and, erson signing this document after making item of information contained in this any individual designated in 37 CFR 3) months prior to the filing date of this		
	X 14	Paym	ent of all applicable fees:			
		∑ 15	• .	ole fees associated with the submittal of e Statement to Deposit Account No.		
An original	and tw	o (2) co	ppies of this document are e	nclosed.		
				Respectfully submitted,		
	30-	Marc	h-0+	an m.a. t		
		Date		Attorney - ANN M. AGOSTI		
General Electric Company			•	Registration No. 37,372		
CRD Patent Docket Rm 4A59 P.O. Box 8, Bldg. K-1				Phone: (518) 387-7713 or (518) 387-7122		
Schenectad	iy, New `	York 12	301	· •		

Customer Number: 006147

Sheet 1 of 1

FORM PTO-1449 (REV. 7-80)	US. DEPARTME	ATTY. DOCKET NO.	SERIAL NO.						
(KEV. 1-60)	PATENT AND TRADEMARK OFFICE		140264						
INFORMATION DISCLOSURE STATEMENT BY APPLIED LIST OF ITEMS		/ APPLICANT	Applicant XIAOLEI SHI, ET AL						
			Filing Date	Group					
	OTHER INFORMATION (Includ	ling Author, Title, Date, 3	Pertinent Pages, etc.)						
C			citation in Silver Nanoparticles: Influence of iew Letters, Vol. 89, No. 25, pp. 257404-1 -						
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EXAMINER	<u></u>		DATE CONSIDERED						
	f reference considered, whether or not citation is in Include copy of this form with next communicatio		509; Draw line through citation	on if not in conformance					